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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of \_\_\_\_\_ : March 28, 2005  
Doris, et al. \_\_\_\_\_ : Group Art Unit: 2818  
Serial No: 10/604,190 \_\_\_\_\_ : Examiner: Mai Huong C. Tran  
Filed: 6/30/03 \_\_\_\_\_ : International Business Machines Corporation  
2070 Route 52  
Hopewell Junction, NY 12533

TITLE: High Performance CMOS Device Structures and Method of Manufacture

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the US and non-US patents and publications as listed on Form PTO-1449, attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,  
Doris, et al.

By Joseph P. Abate 3-28-05  
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FIS920030152US1

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

FIS920030152US1

10/094,190

Applicant(s)  
Bruce B. Doris, et al.

Filing Date  
6/30/03

Group Art Unit  
2818

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,806,584	10-19-04	Fung, et al.	257	900	10/21/02
		6,825,529	11-30-04	Chidambarrao, et al.	257	336	12/12/02

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.